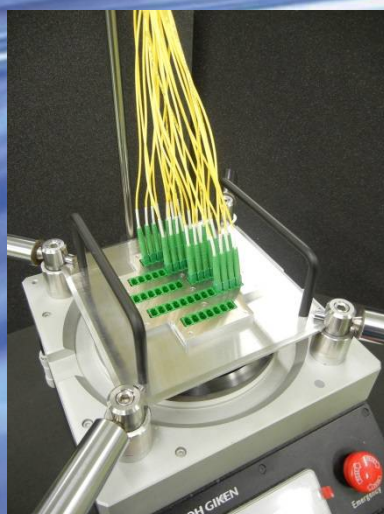
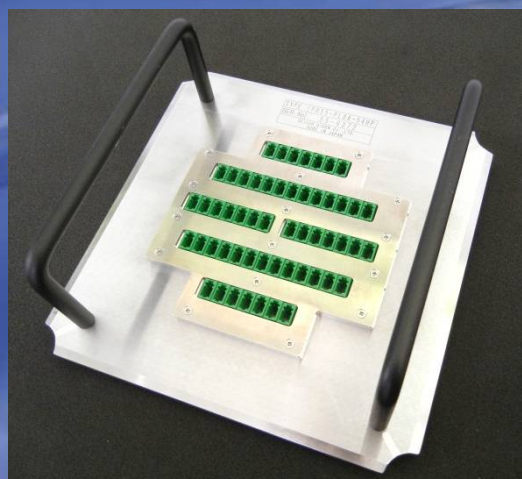




SEIKOH GIKEN



**54ch.
LC/APC
Polishing
holder**

Polishing Holder : PH55-PL8A-54HP (IPC holder)

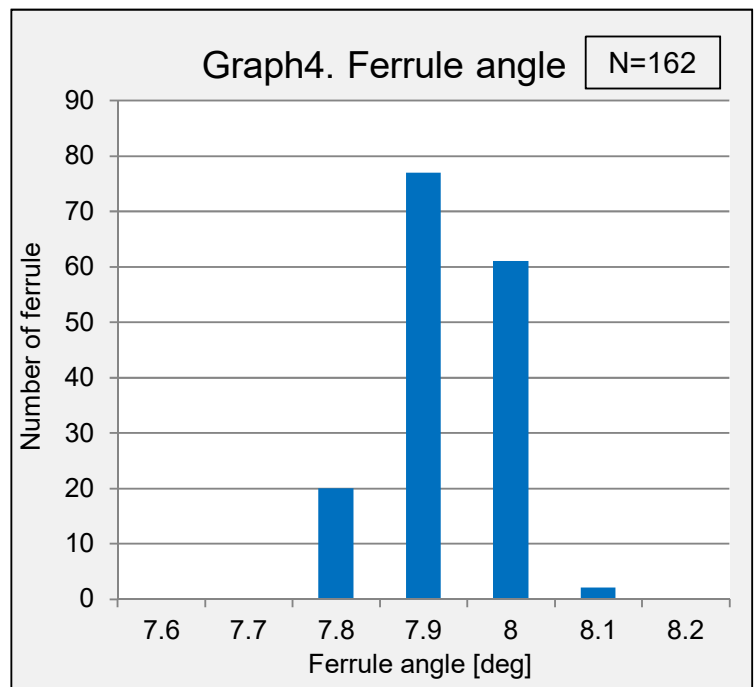
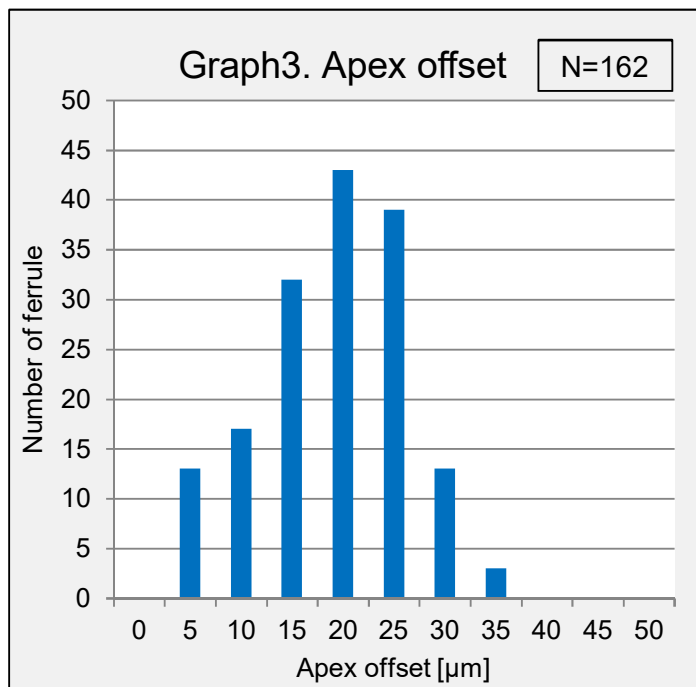
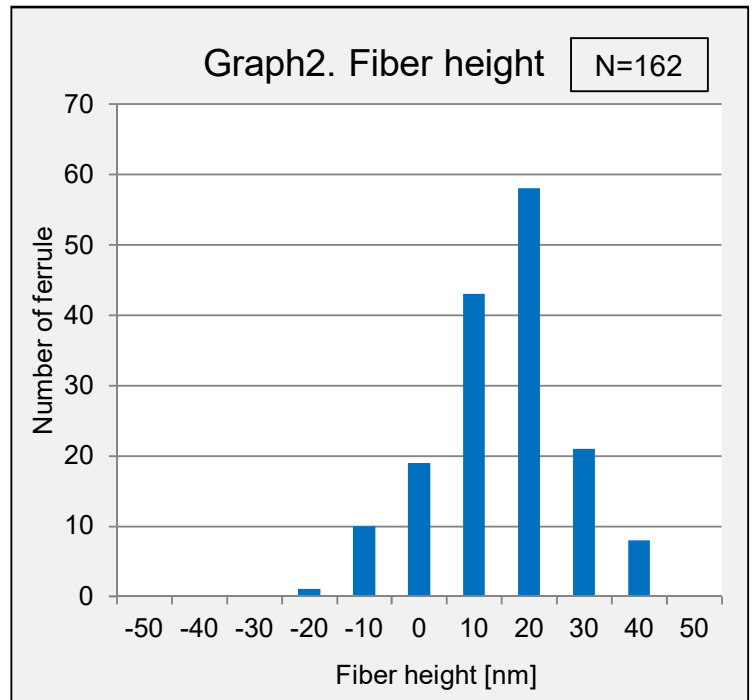
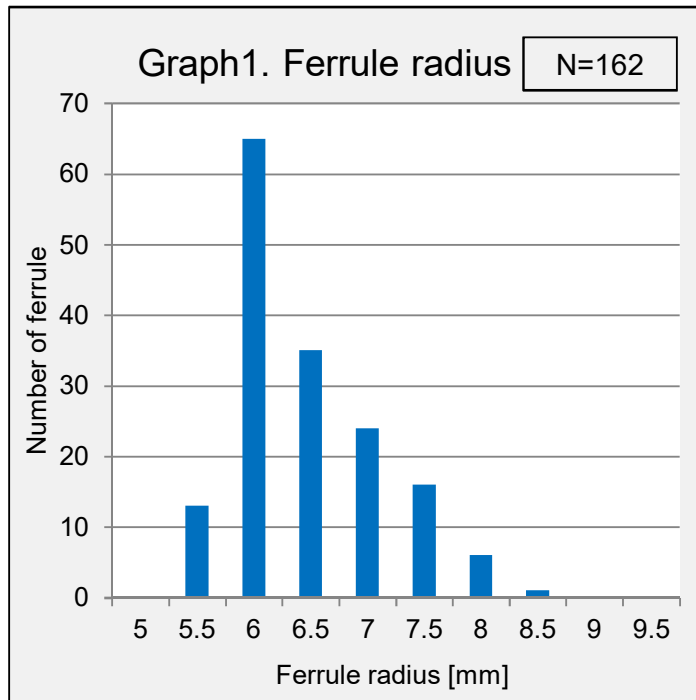
Polishing Machine : SFP-560A, SFP-550 series

■ Features

- Increase production capacity by 12% from existing LC/APC 48 axis holder
- Further stabilization of endface geometry “Apex offset”
- Inherited “IPC technology” to maintain excellent workability as ever

Polishing Process	Polishing Condition					
	Polishing Pad	Film (service life)	Polishing Liquid	Speed (rpm)	Time (sec)	Clamp Lever Pressure
1	PR5X-500-70	GA5D(3)	PURIFIED WATER	110	20	After 20 turntable revolution
2	PR5X-500-70	DR5D(30)	PURIFIED WATER	110	20	After revolution starts
3	PR5X-500-70	DJ5D(15)	PURIFIED WATER	110	40	After revolution starts
4	PR5X-500-70	XF5D(5)	PURIFIED WATER	110	40	After revolution starts

LC/APC 54ch Polishing Holder polishing result



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